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Nanoindentation

With 87 Figures



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Contents

Series Preface.....	vii
Preface.....	ix
List of Symbols.....	xv
Introduction.....	xix
1. Contact Mechanics	1
1.1 Introduction.....	1
1.2 Elastic Contact.....	1
1.3 Geometrical Similarity	6
1.4 Elastic–Plastic Contact.....	8
1.4.1 <i>The constraint factor</i>	8
1.4.2 <i>Indentation response of materials</i>	9
1.4.3 <i>Elastic–plastic stress distribution</i>	10
1.4.4 <i>Hardness theories</i>	11
1.5 Indentations at the Nanometre Scale.....	14
References.....	16
2. Nanoindentation Testing	20
2.1 Nanoindentation Test Data.....	20
2.2 Indenter Types	20
2.3 Indentation Hardness and Modulus	23
2.3.1 <i>Spherical indenter</i>	24
2.3.2 <i>Vickers indenter</i>	25
2.3.3 <i>Berkovich indenter</i>	25
2.3.4 <i>Cube corner</i>	26
2.3.5 <i>Knoop hardness</i>	26
2.4 Load-Depth Compliance Curves.....	27
2.5 Experimental Techniques.....	30
2.5.1 <i>Basic instrument construction and installation</i>	30
2.5.2 <i>Indenters</i>	31
2.5.3 <i>Specimen mounting</i>	32
2.5.4 <i>Working distance and initial penetration</i>	33
2.5.5 <i>Test cycles</i>	34
References.....	35

3. Analysis of Nanoindentation Test Data	36
3.1 Analysis of Indentation Test Data.....	36
3.2 Analysis Methods	36
3.2.1 <i>Cylindrical punch indenter</i>	36
3.2.2 <i>Conical indenter — cylindrical punch method</i>	38
3.2.3 <i>Spherical indenter</i>	40
3.2.3.1 <i>Multiple-point unload method</i>	42
3.2.3.2 <i>Single-point unload method</i>	43
3.2.4 <i>Berkovich indenter</i>	44
3.2.4.1 <i>Multiple-point unload method</i>	46
3.2.4.2 <i>Single-point unload method</i>	47
3.2.5 <i>Knoop indenter</i>	48
3.2.6 <i>Hardness as a function of depth</i>	51
3.2.7 <i>Energy methods</i>	53
3.2.8 <i>Dynamic methods</i>	55
3.2.9 <i>Other methods of analysis</i>	56
References.....	58
4. Factors Affecting Nanoindentation Test data	61
4.1 Introduction.....	61
4.2 Thermal Drift	61
4.3 Initial Penetration Depth	62
4.4 Instrument Compliance	65
4.5 Indenter Geometry	67
4.6 Piling-Up and Sinking-In	71
4.7 Indentation Size Effect	74
4.8 Surface Roughness	76
4.9 Tip Rounding	77
4.10 Residual Stresses	79
4.11 Specimen Preparation.....	80
References.....	81
5. Simulation of Nanoindentation Test Data	83
5.1 Introduction.....	83
5.2 Spherical Indenter.....	83
5.3 Berkovich Indenter	85
5.4 Other Indenters	86
5.5 Comparison with Experimental Data.....	87
References.....	89
6. Scaling Relationships in Nanoindentation.....	90
6.1 Scaling Relationships in Nanoindentation.....	90
References.....	94

7. Methods of Nanoindentation.....	96
7.1 Introduction.....	96
7.2 Dynamic Indentation Testing.....	96
7.3 Thin Films.....	100
7.3.1 Elastic modulus.....	101
7.3.2 Hardness.....	103
7.3.3 Film adhesion.....	104
7.4 Scratch Testing.....	105
7.5 Acoustic Emission Testing.....	108
7.6 Constant Strain Rate Testing.....	110
7.7 Creep.....	111
7.8 Fracture Toughness.....	113
7.9 High-Temperature Nanoindentation Testing.....	116
7.10 Strain-hardening exponent.....	119
7.11 Impact.....	120
References.....	122
8. Nanoindentation Test Standards.....	126
8.1 Nanoindentation Test Standards.....	126
8.2 ISO 14577.....	126
8.2.1 ISO 14577 Part 1: Test method.....	128
8.2.1.1 Test method and requirements.....	128
8.2.1.2 Analysis procedures.....	129
8.2.1.3 Load and Depth Control.....	135
8.2.1.4 Diamond Indenters.....	135
8.2.1.5 Specimen Roughness.....	135
8.2.1.6 Instrument Compliance and Indenter Area Function.....	136
8.2.1.7 Correlation of H_{IT} with Other Scales.....	137
8.2.2 ISO 12577 Part 2: Verification and calibration of machines.....	137
8.2.2.1 Indenters.....	137
8.2.2.2 Calibration of force and depth.....	139
8.2.2.3 Verification of compliance and area function.....	139
8.2.2.4 Verification of the instrument.....	139
8.2.2.5 Annexes to Part 2.....	140
8.2.3 ISO 12577 Part 3: Calibration of reference blocks.....	140
References.....	141
9. Nanoindentation Test Instruments.....	142
9.1 Specifications of Nanoindentation Test Instruments.....	142
9.2 “Nano Indenter [®] ,” MTS Systems Corporation.....	146
9.3 “NanoTest [®] ,” Micro Materials Ltd.....	147
9.4 “TriboIndenter [®] ,” Hysitron Inc.....	150
9.5 “Nano-Hardness Tester [®] ,” CSEM Instruments.....	153

9.6 “UMIS®,” CSIRO.....	155
References	158
10. Examples of Nanoindentation Testing	159
10.1 Introduction	159
10.2 Fused Silica	160
10.3 Titanium Dioxide Thin Film	161
10.4 Superhard Thin Film	162
10.5 Diamond-like Carbon (DLC) Thin Film	163
10.6 Creep in Polymer Film	164
10.7 Fracture and Delamination of Silicon Oxide Film.....	166
10.8 High-Temperature Testing on Fused Silica	167
10.9 Adhesion Measurement	168
10.10 Dynamic Hardness	169
10.11 Repeatability Testing.....	170
10.12 Assessment of Thin Film Adhesion by Scratch Testing.....	171
10.13 Other Applications	172
References	173
Appendix 1 Elastic Indentation Test Fields	174
A1.1 Contact Pressure Distributions	174
A1.2 Indentation Stress Fields.....	175
<i>A1.2.1 Spherical indenter</i>	175
<i>A1.2.2 Conical indenter</i>	177
Appendix 2 Surface Forces, Adhesion and Friction.....	179
A2.1 Adhesion Forces in Nanoindentation.....	179
A2.2 Forces in Nature	179
A2.3 Interaction Potentials	180
A2.4 Van der Waals Forces.....	181
A2.5 Surface Interactions	182
A2.6 Adhesion.....	184
A2.7 Friction	188
Appendix 3 Common Indenter Geometries.....	191
A3.1 Berkovich Indenter	191
A3.2 Vickers Indenter	192
A3.3 Knoop Indenter	193
A3.4 Sphero-Conical Indenter.....	194
Index	195